

SENSOR PROCESSING METHOD AND APPARATUS

Abstract of the Disclosure

Sensor information from a plurality of sensors that monitor an apparatus is accessed and then sensed information that corresponds to that sensor information is input into a control circuit configured to output virtual parameters corresponding to the apparatus as a function, at least in part, of the sensed information. A particular fault class is determined from amongst a plurality of fault classes as a function, at least in part, of the virtual parameters and at least one task is identified regarding the apparatus that corresponds to the particular fault class.

[Fig. 4]